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|  | First Named Inventor Seiji |       | eiji Yamamoto et al |  |
|  | Art Unit                   |       | 3737                |  |
| notion submission and or or it not,  | Examiner Name              | Josep | oh M. Santos        |  |
|  | Attorney Docket Numb       | er    | 051223-110922       |  |

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|  | Art Unit              |         | 3737           |            |          |  |
|  | irst Named Inventor   | Seiji Y | 'amamoto et al |            |          |  |
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| Receipt date: 04/29/2010 Apr   | Application Number    |         | 10599487       | 10599487 - | GAU: 373 |  |

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